





IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Tetsuo YAMADA, et al.

Serial No.

10/518,704

For

THIN FILM PIEZOELECTRIC RESONATOR, THIN

FILM PIEZOELECTRIC DEVICE, AND

MANUFACTURING METHOD THEREOF (As Amended)

Filing Date

December 17, 2004

Examiner

Tonya Lee

Group Art Unit

2834

Confirmation No.

5674

745 Fifth Avenue New York, NY 10151

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on May 8, 2006.

onald R. Santucci, Reg. No. 28,988

stered Representative

May 8, 2006

Date of Signature

STATUS INQUIRY

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Applicants respectfully request the status of the above referenced patent application.

This application was filed on December 17, 2004 and to date no Official Action has yet issued.

The last communication regarding this application was the notice advising that assignment of the application was recorded on December 17, 2004.

Respectfully submitted,

FROMMER LAWRENCE & HAUG LLP

By:

Reg. No. 28,988 (212) 588-0800